



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 2, 2026

IGI Report Number

LG797630870

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

OVAL BRILLIANT

Measurements

8.21 X 5.49 X 3.42 MM

GRADING RESULTS

Carat Weight

1.06 CARAT

Color Grade

D

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

VERY GOOD

Fluorescence

NONE

Inscription(s)

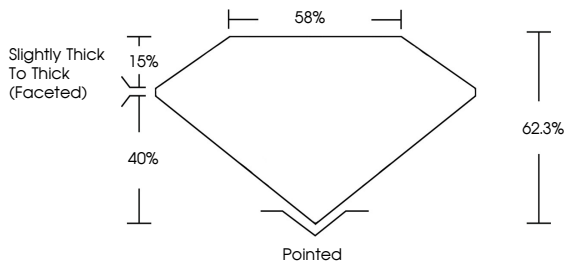
 LG797630870

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

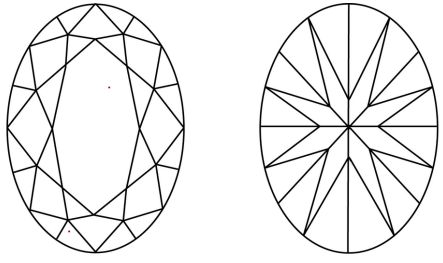
LG797630870

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



© IGI 2020, International Gemological Institute

FD - 10 20



May 2, 2026

IGI Report Number

LG797630870

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

OVAL BRILLIANT

Measurements

8.21 X 5.49 X 3.42 MM

GRADING RESULTS

Carat Weight

1.06 CARAT

Color Grade

D

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

VERY GOOD

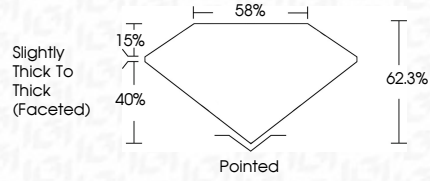
Fluorescence

NONE

Inscription(s)

 LG797630870

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



May 2, 2026

IGI Report No LG797630870

OVAL BRILLIANT

8.21 X 5.49 X 3.42 MM

Carat Weight

1.06 CARAT

D

Color Grade

D

VVS 2

Clarity Grade

VVS 2

62.3%

Depth

62.3%

Slightly Thick To Thick (Faceted)

Girdle

Slightly Thick To Thick (Faceted)

Pointed

Culet

Pointed

EXCELLENT

Polish

EXCELLENT

VERY GOOD

Symmetry

VERY GOOD

NONE

Fluorescence

NONE

 LG797630870

Inscription(s)

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa